

Docket No.: TCP-005

1AF20 RECEIVED 27 FEB 2006
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	
	:	Confirmation No.
Shojiro KOMATSU et al	:	
	:	
U.S. Patent Application No.: -----	:	Group Art Unit: -----
	:	
Filed: <i>herewith</i>	:	

For: FILM OF SP³-BONDED BORON NITRIDE HAVING A SELF-ORGANIZED
SURFACE TEXTURE CAPABLE OF PROMOTING FIELD ELECTRON EMISSION,
METHOD FOR PRODUCING THE SAME AND USE THEREOF

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Preliminary to examination of the above-referenced application, please amend the application as follows:

Amendments to the Claims begins on page 2 of this paper.

Remarks begins on page 6 of this paper.